



The 10th Asian-European International Conference on Plasma Surface Engineering
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AEPSE 2015



Name	Seongjun Park
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Education

period	Details
90.03 ~ 94.02	B.S. in Chemical Engineering, Seoul National University, Seoul, Korea
97.08 ~ 99.03	M.S. in Chemical Engineering, Stanford University, California, US
99.04 ~ 03.06	Ph.D. in Chemical Engineering, Stanford University, California, US

Professional experience

Period	Details
03.07 ~ 05.08	Research Associate, in Mechanical Engineering, Stanford University, California, US
05.08 ~ 10.06	Senior Software Engineer, Technology Manufacturing Group, Intel Corporation, California, US
10.07 ~ 13.02	Research Staff Member, Samsung Advanced Institute of Technology (SAIT) Samsung Electronics, Gyeonggi-do, Korea
13.03 ~ 13.11	Research Master, SAIT Samsung Electronics, Gyeonggi-do, Korea
13.12 ~ Present	Vice President, SAIT Samsung Electronics, Gyeonggi-do, Korea

Organizational experience

Period	Details